

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Peter STAUSS et al.

Serial No.: 10/544,159

Filed: March 13, 2006

For: Thin-Film Semiconductor Component and
Production Method for said Component

Examiner: Weiss, Howard
Group Art: 2814

Conf. No.: 8419

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

S I R:

In compliance with the duty of disclosure under 37 C.F.R. §1.56 and in accordance with the practice under 37 C.F.R. §§1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO/SB/08A. Copies of the listed non-US documents are also enclosed.

This information is being submitted subsequent to the later of three months after the filing date of the present application, but before the mailing of a final Action or the Notice of Allowance.

Each item of information contained in the Information Disclosure Statement was cited in an Office Action received from the Japanese Patent Office in the corresponding Japanese patent application not more than three months prior to the filing of the Information Disclosure Statement.

US 5,196,354 corresponds to JP 3-102876.

JP 2001-501778 corresponds to US 6,559,075 previously filed with PTO on August 1, 2005.

In accordance with 37 C.F.R §§1.97(g) and (h), the filing of this Information Disclosure Statement should not be construed as a representation that a search has been made or that information cited is, or is considered to be, material to patentability as defined in §1.56(b), or that any cited document listed or attached is (or constitutes) prior art. Unless otherwise indicated, the date of publication indicated for an item is taken from the face of the item and Applicants reserve the right to prove that the date of publication is in fact different.

It is believed that no fees or charges are required at this time in connection with the present application. However, if any fees or charges are required at this time, they may be charged to our Patent and Trademark Office Deposit Account No. 03-2412.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO/SB/08A be returned indicating that such information has been considered.

Respectfully submitted,
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